

Form PTO-1449

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

First Named Inventor	Jochen Koetke
Title	Operation Microscope with an Illuminating Device
Application No.	10/085,644
Filing Date	10/15/03
Group Art Unit	2872
Examiner Name	Lavarias
Attorney Docket No.	GMH/411/US
Date	October 10, 2003

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>AK</i>	5,943,118	8/24/99	Koschmieder et al	351	243	
<i>AK</i>	5,135,299	8/4/92	Kitajima et al	351	205	

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
<i>AK</i>	DE198 56 847 A	June 17, 1999	Germany	—	—	<input type="checkbox"/>	<input checked="" type="checkbox"/>
						<input type="checkbox"/>	<input type="checkbox"/>
						<input type="checkbox"/>	<input type="checkbox"/>
						<input type="checkbox"/>	<input type="checkbox"/>

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>AK</i>	EXAMINER INITIAL	Patent Abstracts of Japan Vol. 004, No. 168 (P-037), November 20, 1980
EXAMINER	<i>Samuel C. Lavarias</i>	DATE CONSIDERED <i>11/19/05</i>

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.